

DAFTAR PUSTAKA

- Alonso, M. dan Edward, J.F. 1967. *Fundamental University Physics*. Vol.II Fields and Wave. Addison-Wesley Publishing.
- Berger, James O. 1985. *Statistical Decision Theory and Bayesian Analysis* (2nd ed.). Springer-Verlag, New York.
- Bueche, F.J. dan David, A.J. 1995. *Prinsiples of Physics*. New York: McGraw-Hill Inc.
- Czapka, Tomasz. 2011. Back-Corona Discharge Phenomenon in the Nonthermal Plasma System. *IEEE Transactions on Plasma Science*. New York.
- Chen, J. dan Davidson, J.H. 2002. Electron Density and Energy Distributions in the Positive DC Corona: Interpretation for Corona-Enhanced Chemical Reactions. *Plasma Chemistry and Plasma Processing*. Vol. 22.
- Davidson, J.H. 2000. *Recent Trends In Electrostatic Precipitation*. New York: McGraw-Hill Inc.
- Duffy, A. 1999. *Electric Charge and Coulomb's Law, Physics Lecture Demonstration*. Massachusetts: Boston University.
- E., Kuffel, W.S., Saengl, J., Kuffel. 2000. *High Voltage Engngineering Fundamental*. Published by Butterworth-Heinemann. Typeset by Laser Words, Madras, India.
- Francis, F.C. 1974. *Introduction to Plasma Physics*. Plenum Press. New York.
- Furuhi, Tomoshige, Kawata, Shuichi, dan Takada, Takahiro. 2015. Properties of Novel Atmospheric Pressure Plasma Generator Inducing Surface Airflow by Scanning Discharge. *IEEE Trans. Dielectrics and Electrical Insulation*, Vol. 20, pp. 1101-1111. New York.
- Hayt, W.G. 1982. *Teknologi Elektromagnetik*. Edisi keempat alih Bahasa Houw Liong. Jakarta: Erlangga.
- Iskander, M.F. 1992. *Electromagnetic Fields and Waves*. New Jersey: Prentice Hall Inc.
- Kind, D. 1993. *Pengantar Teknik Ekspremental Tegangan Tinggi*. Bandung: ITB.
- Kim, H.H. Prieto, G., Takashima, K., Katsura, S., Mizuno, A. 2002. Performance Evaluation of Discharge Plasma for Gaseous Pollutant Removal. *Journal of Electrostatic Elsevier* Vol. 55.
- Krasilnikov, Mikhail B., dan Kudryavtsev, Anatoly A. 2005. The Influence Of Ambipolar Electric Field On The Edf Formation And The Electron Processes In Partially Ionized Plasmas. *Principles of Plasma Discharges and Material Processing*. Wiley, New York.
- Lehmann, E. L., Casella, George. 1998. *Theory of Point Estimation* (2n ed.). Springer, New York.
- Li, Dashuai, Tong, Ling, Gao, Bo, dan Tian, Yu. 2015. The Study of 2.45 GHz Atmospheric Microwave Plasma Generator. *IEEE Transaction on Industry Applications*. Vol. 15. New York.
- M.S., Naidu. 1995. *High Voltage Engngineering*. Second Edition. New York: McGraw-Hill Inc.

- Nur, Muhammad. 2011. *Fisika Plasma dan Aplikasinya*. Universitas Diponegoro. Semarang.
- Petry, Robert L. 1926. Secondary Electron Emission from Tungsten, Copper, and Gold. *Physical Review*, Vol. 28, pp. 362-366. Virginia.
- Raizer, Yu P. 1991. *Gas Discharge Physics*. Berlin: Springer-Verlag.
- Shimizu, K., Kinoshita, K., Yanagihara, K., Rajanikanth, B.S., Katsura, S., and Mizuno A. 1997. Pulsed-Plasma Treatment of Polluted Gas Using Wet/Low-Temperature Corona Reactors. *IEEE Transaction on Industry Applications*. Vol 33.
- Smith, H.B, Charles, C., dan Boswell, R.W. 2010. Breakdown Voltage on Argon Radio-Frequency Discharge. *Plasma Chemistry and Plasma Processing*. Vol. 22.
- Storr, Wayne. 2015. *Basic Electronics Tutorials*.
- Sumanto. 1979. *Transformator*. Jogjakarta: Andi Offset.
- Teske, Christian James, and Jacoby, Joachim. 2008. Pulsed Low Frequency Inductively Coupled Plasma Generator and Applications. *IEEE Transactions on Plasma Science*. New York.
- Trujillo, Sánchez, Brian, Ángel, Méndez, Martínez, Rigoberto, Rodríguez, Portillo, and Otniel. 2016. Prototype of a Plasma Generator for Electrosurgery. *13th International Conference on Power Electronics*. Toluca, Mexico.
- Wen, Xishan, Yuan, Xiaoqing, Lan, Lei, Long, Mengjiao, dan Hao, Lu. 2016. Study on the Effective Ionization Rate of Atmospheric Corona Discharge Plasmas by Considering Humidity. *IEEE Transactions On Plasma Science*. New York.

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